

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 5483

Bradley J. Aitchison et al.

Application No. 10/660,365

Filed: September 10, 2003

For: **PRECURSOR MATERIAL DELIVERY
SYSTEM FOR ATOMIC LAYER
DEPOSITION**

Group Art Unit: 1724

Examiner: Jason M. Greene

Date: April 11, 2006

TRANSMITTAL LETTER

TO THE COMMISSIONER FOR PATENTS:


Enclosed for filing in the above-referenced application are the following:

- ☒ Amendment
- ☒ Fourth Supplemental Information Disclosure Statement
- ☒ Form PTO/SB/08a

The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455.

Respectfully submitted,

Planar Systems, Inc.

By 
Kassim M. Ferris
Registration No. 39,974

STOEL RIVES LLP
900 SW Fifth Avenue, Suite 2600
Portland, OR 97204-1268
Telephone: (503) 224-3380
Facsimile: (503) 220-2480
Attorney Docket No. 11429/12:2